

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
HYUN MIN SONG	05/30/2017
JAE UK LEE	05/30/2017
SEUNG MIN LEE	05/30/2017
JUNG HWAN KIM	05/30/2017
RECEIVING PARTY DATA	
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State/Country:	KOREA, REPUBLIC OF
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	14825572
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NAME OF SUBMITTER:	RICHARD J. STREIT
SIGNATURE:	/RICHARD J. STREIT/
DATE SIGNED:	06/19/2017
Total Attachments: 2	
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source=2017-06_19_cu72364_assignment_inv4-7#page2.tif	

UNITED STATES OF AMERICA
ASSIGNMENT

In consideration of the payment of ASSIGNEE to ASSIGNOR of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration,

ASSIGNOR:

Hyun Min SONG

Jae Uk LEE

Seung Min LEE

Jung Hwan KIM

hereby sells, assigns and transfers to

ASSIGNEE:

**IUCF-HYU(INDUSTRY-UNIVERSITY COOPERATION FOUNDATION
HANYANG UNIVERSITY)**

Hanyang Institute of Technology BD, Hanyang University, 222
Wangsimni-ro, Seongdong-gu, Seoul, Korea

and the successors, assigns and legal representatives of the ASSIGNEE the entire right, title and interest for the United States and its territorial possessions in and to, any and all improvements which are disclosed in the Application entitled MASK FOR EXTREME ULTRAVIOLET LITHOGRAPHY PROCESS AND METHOD OF FABRICATING THE SAME and which is found in

U.S. Serial No. 14/825,572 filed August 13, 2015

and, in and to, all Letters Patent to be obtained for said invention by the above application or any continuation, division, renewal, or substitute thereof, and as to letters patent any reissue or re-examination thereof.

ASSIGNOR hereby covenants that no assignment, sale, agreement or encumbrance has been or will be made or entered into which would conflict with this assignment and sale.

ASSIGNOR further covenants that ASSIGNEE will, upon its request, be provided promptly with all pertinent facts and documents relating to said invention and said Letters Patent and legal equivalents as may be known and accessible to ASSIGNOR and will testify as to the same in any interference, litigation or proceeding related thereto and will promptly execute and deliver to ASSIGNEE or its legal representatives any and all papers, instruments or affidavits required to apply for, obtain, maintain, issue and enforce said application, said invention and said Letters Patent and said equivalents thereof which may be necessary or desirable to carry out the purposes thereof.

IN WITNESS WHEREOF, we have set our hand and seal

2017. 05. 30

Date

송민

Hyun Min SONG

2017. 05. 30

Date

이재욱

Jae Uk LEE

2017. 05. 30

Date

민서

Seung Min LEE

2017. 05. 30

Date

김정환

Jung Hwan KIM

L&P 09/2012 (Assignment - entire interest - US rights only)